



MICRO-429:

Metrology Practicals

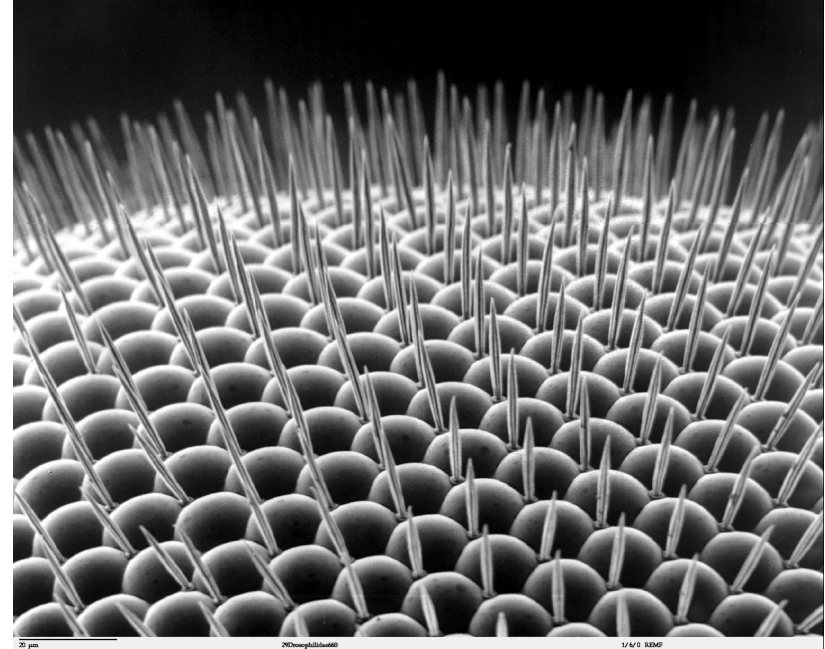
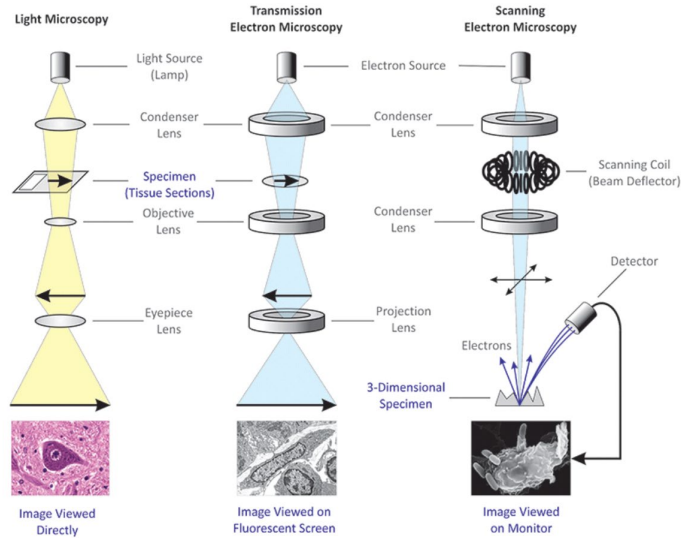
T1: SEM

Marcos Penedo
Mahdi Mehdikhani
Georg Fantner
LBNI, EPFL

SEM: Scanning electron microscopy

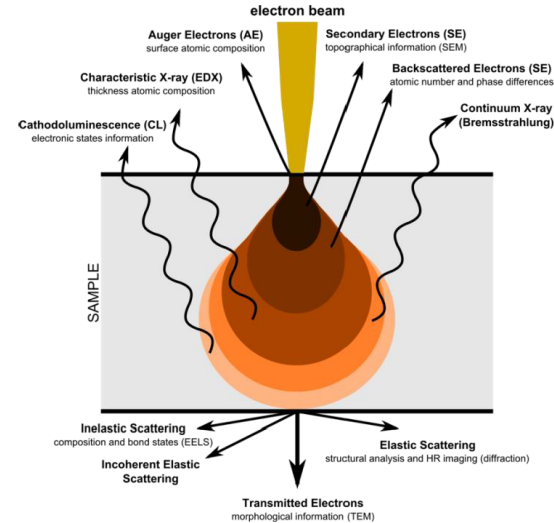
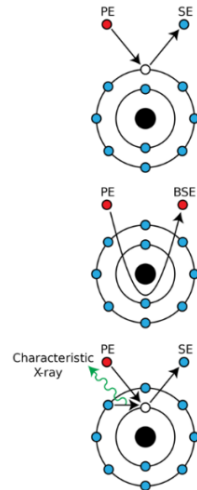


SEM: Scanning electron microscopy

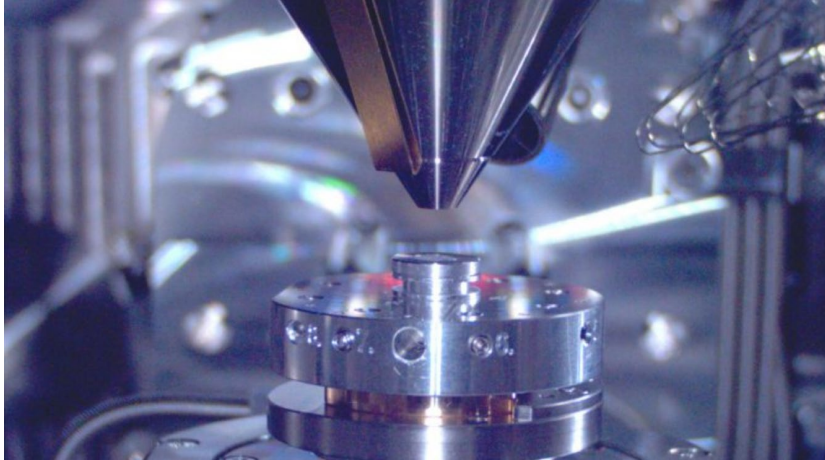


The eye of the fruit fly
(Louisa Howard, Dartmouth Electron Microscope Facility)

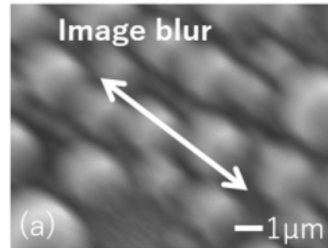
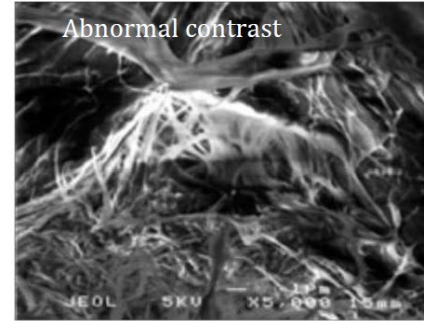
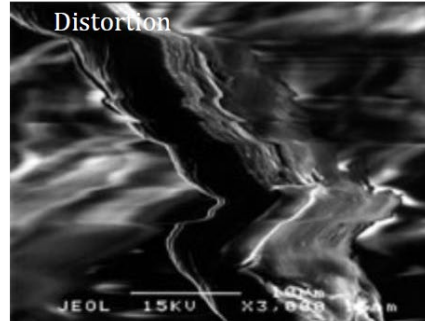
- How SEM works
 - Different types of detectors in the SEM
 - Effects of changing imaging parameters on the quality (e.g acceleration voltage and current)



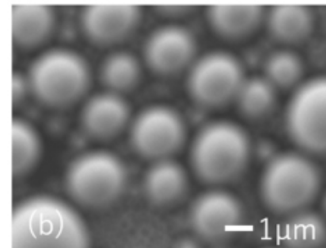
- Basics of operating a SEM



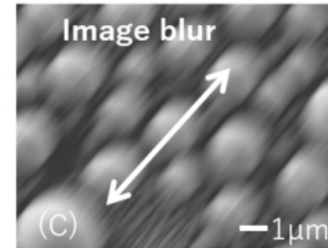
- Image artefacts (charging, astigmatism)



Over focus

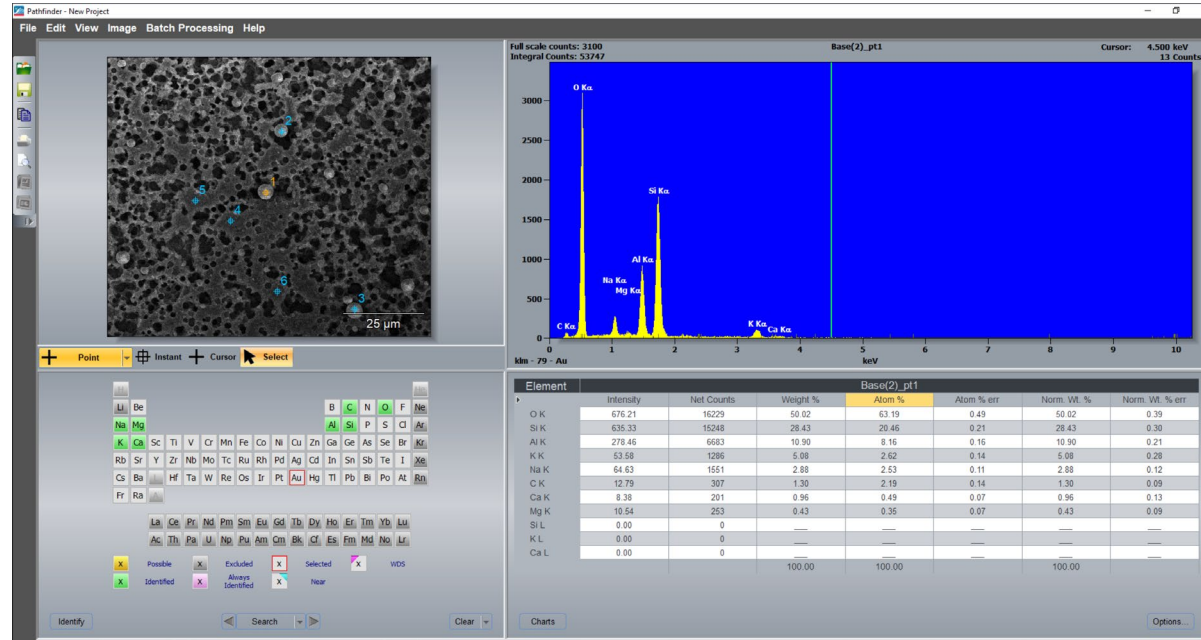


Exact focus



Under focus

- EDX (Energy Dispersive X-ray spectroscopy)
 - Elemental analysis and mapping



[Google Map](#)

